



PATENT  
1794-0141P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: Yoshinobu AOYAGI et al. Conf.: 6758  
Appl. No.: 09/941,612 Group: 1765  
Filed: August 30, 2001 Examiner: UNKNOWN  
For: IMPURITY DOPING METHOD FOR SEMICONDUCTOR  
AS WELL AS SYSTEM THEREFOR AND  
SEMICONDUCTOR MATERIALS PREPARED THEREBY

RECEIVED

NOV 26 2001

LETTER

TC 1700

Assistant Commissioner for Patents  
Washington, DC 20231

November 19, 2001

Sir:

Enclosed herewith is a Supplemental Declaration that should be made part of the record of the present application.

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to Deposit Account No. 02-2448 for any additional fee required under 37 C.F.R. §§ 1.16 or 1.17; particularly, extension of time fees.

Respectfully submitted,

BIRCH, STEWART, KOLASCH & BIRCH, LLP

By Joe McKinney Muncy, #32,334

KM/ghh  
1794-0141P

P.O. Box 747  
Falls Church, VA 22040-0747  
(703) 205-8000

Attachment